2025 年度シラバス

科目分類/Subject Categories				
学部等/Faculty	学部等/Faculty /大学院工芸科学研究科(博士前期課程):		/有:/Available	
	/Graduate School of Science and			
	Technology (Master's Programs)			
学域等/Field	/物質・材料科学域 : /Academic Field of	年次/Year	/1~2年次:/1st through 2nd	
	Materials Science		Year	
課程等/Program	/材料制御化学専攻:/Master's Program of	学期/Semester	/春学期:/Spring term	
	Material's Properties Control			
分類/Category	/授業科目:/Courses	曜日時限/Day & Period	/:/	

科目情報/Course Info	科目情報/Course Information				
時間割番号					
/Timetable Number					
科目番号	61760019				
/Course Number					
単位数/Credits	2				
授業形態	講義・演習:Lecture/Pra	cticum			
/Course Type					
クラス/Class					
授業科目名	Science and Technology of	of Functional I	Materials : Sc	ience and Technology of Fu	ınctional Materials
/Course Title					
担当教員名	/トリノエ科大学教員(材料	料創製化学専巧	女および材料制	御化学専攻ダブル・ディグ	`リープログラムコース):
/ Instructor(s)	Related teacher of Polyt	technic Unive	rsity of Turin	(Double Degree Program	n course in the Master's
	Program of Innovative Ma	aterials and M	aterial's Prop	erties Control)	
その他/Other	インターンシップ実施科	国際科学技術	ドコース提供	PBL 実施科目 Project	DX 活用科目
	目 Internship	科目 IGP		Based Learning	ICT Usage in Learning
	実務経験のある教員によ				
	る科目				
	Practical Teacher				
科目ナンバリング			·		·
/Numbering Code					

授業	の目的・概要 Objectives and Outline of the Course
日	
英	The aim of the course of Science and Technology of Functional Materials is to help students to know the semiconductor
	materials class and the problems connected to the concept of functional material. The course is about: the theory necessary
	to understand the behavior of a semiconductor, the mode of operation of some basic devices, the technological processes
	used for the preparation of the semiconductor materials and for the building of the devices, some characterization
	techniques, some innovative materials, processes and applications in the field of functional materials. Another objective of
	the course is also for the students to familiarize with the calculations typical of the semiconductors field, through well-aimed
	exercises, and to develop the ability of explaining and presenting subjects close to those treated in the course, through group
	exercises and laboratory experiences.

学習	学習の到達目標 Learning Objectives		
日	to know the semiconductor materials class and the problems connected to the concept of functional material		
英	to know the semiconductor materials class and the problems connected to the concept of functional material		

学習	学習目標の達成度の評価基準 / Fulfillment of Course Goals(JABEE 関連科目のみ)		
日			
英			

授業	計画項	目 Course Plan	
No.		項目 Topics	内容 Content
1	日		
	英	Classification of materials	Semiconducting materials.
2	日		
	英	Properties of materials, with a particular attention to semiconducting materials	crystallography and defects, electrical, thermal, magnetic and optic properties, elements on nanoscale materials properties.
3	日		
	英	Transport in semiconductors	Doping. PN junction. Transistors.
4	日		
	英	Precursors of silicon and of III- V materials	Growth of monocrystals of Si, III-V materials and other semiconductors.
5	日		
	英	Wafering of substrates and process control(1)	Wafering of substrates and process control(1)
6	日		
	英	Wafering of substrates and process control(2)	Integrated circuits technology. Optoelectronic devices technology.
7	日		
	英	Characterization techniques	Optical and electronic microscopy, SPM microscopies, elements of RBS, SIMS.
8	日		
	英	Nucleation and crystal growth	Epitaxial growth techniques. Heterojunctions. Quantum wells. Optoelectronic devices.
9	日		
	英	Optical fibers	Materials for photonic devices. Materials for photovoltaics.
10	日		
	英	Safety of materials	Recycle of functional materials, responsible engineering.
11	日		
	英	Exercises of calculations	Waves and particles, transport in semiconductors, PN junction, diffusion.
12	日		
	英	Group exercised and laboratories(1)	Dismounting of electronic equipment, cutting and preparation of sample for observation at optical and electronic microscope.
13	日		
	英	Group exercised and laboratories(2)	Discussion workshop on hot topics close to the subject of the course.
14	日		
	英	Presentation(1)	Presentations of group exercised and laboratories in this course.
15	日		
	英	Presentation(2)	Presentations of group exercised and laboratories in this course.

履修	条件 Prerequisite(s)
日	
英	

授業	受業時間外学習(予習・復習等)		
Req	Required study time, Preparation and review		
日			
英	The course will be organized with: - lectures; - exercises in the classroom (with particular attention to the ability of carry out		
	complex calculations without errors); - group exercise and laboratories, based on the analysis of real electronic devices; -		
	discussion workshops; - seminars on themes in line with the course topic.		

教科	教科書/参考書 Textbooks/Reference Books		
日			
英	No single textbook exists, the references will be given during the course. However, as a general reference, the following		
	books are suggested: - Sze. Semiconductor devices, Wiley - a book on microfabrication, for instance: Franssila. Introduction		
	to micro		

成績	評価の方法及び基準 Grading Policy
日	
英	Compulsory oral exam; Individual essay; Paper-based written test with video surveillance of the teaching staff; Computer-
	based written test with open-ended questions or multiple-choice questions using the Exam platform and proctoring tools.
	Written test;

留意	事項等 Point to consider
日	
英	